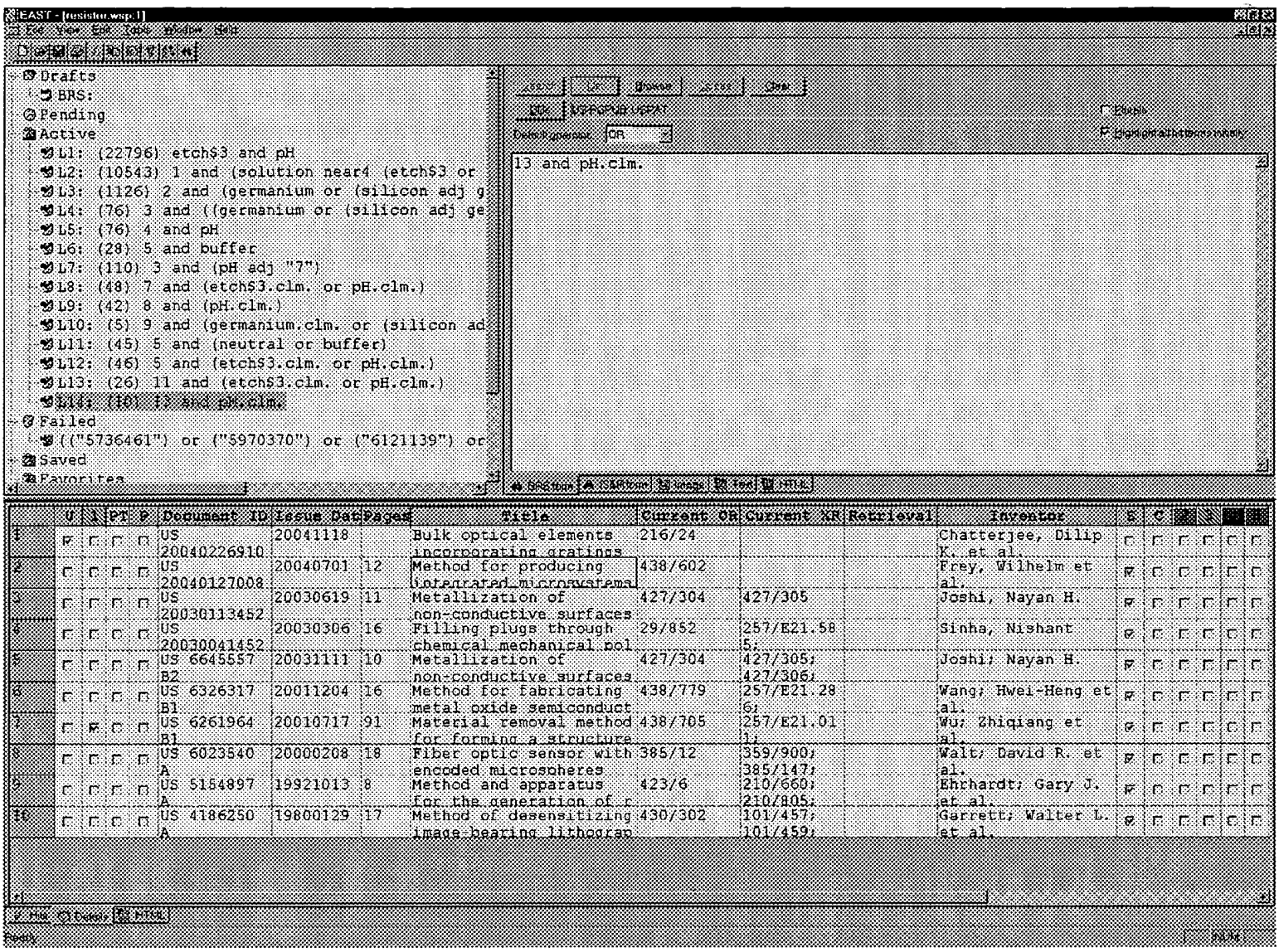
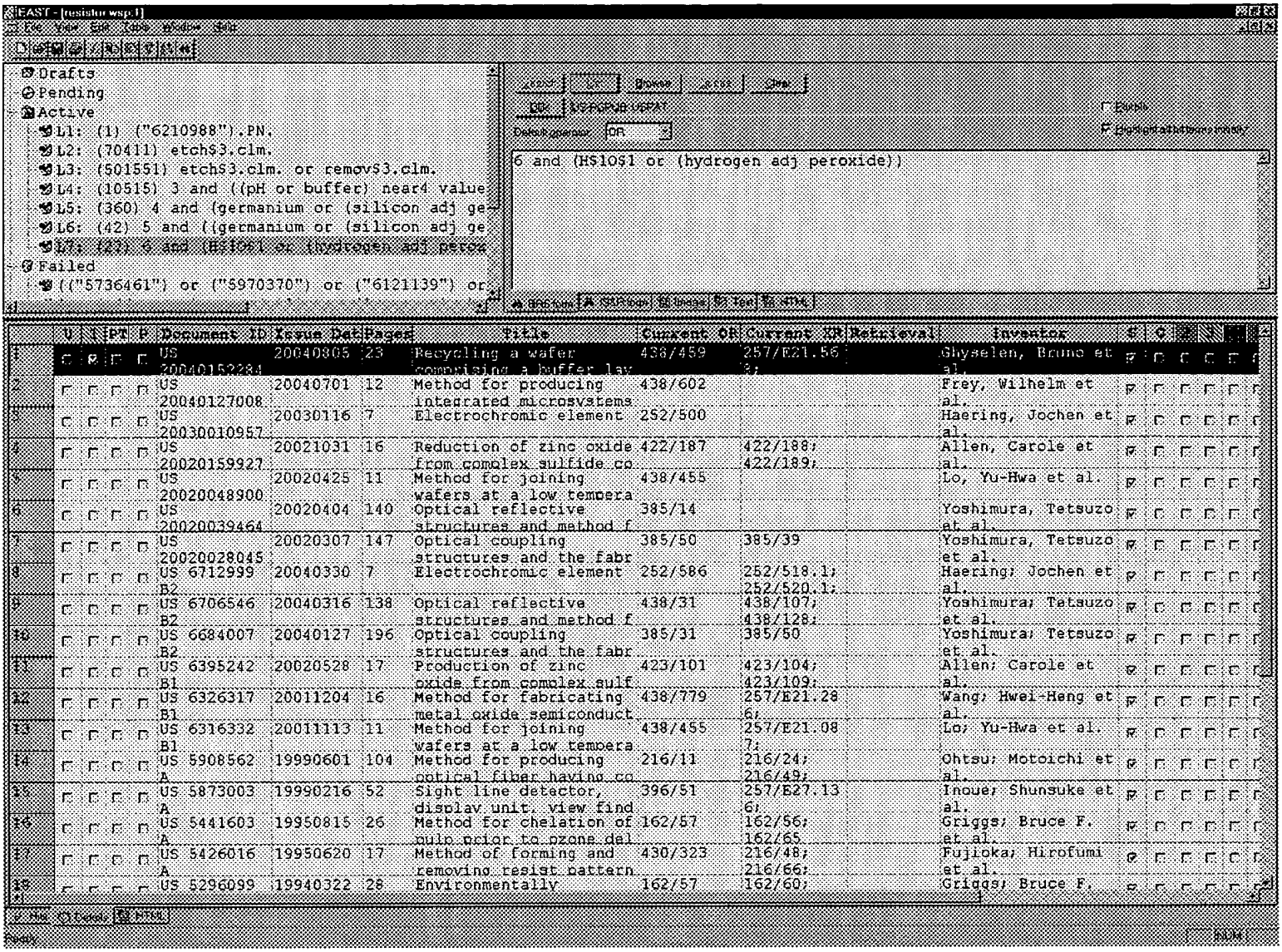


	U	I	PT	P	Document ID	Issue Dat	Pages	Title	Current OR	Current XR	Retrieval	Inventor	S	C
1	☑	☐	☐	☐	US 20040226910	20041118		Bulk optical elements incorporating gratings	216/24			Chatterjee, Dilip K. et al.	☐	☐
2	☐	☐	☐	☐	US 20040127008	20040701	12	Method for producing integrated microwaterma	438/602			Frey, Wilhelm et al.	☑	☐
3	☐	☐	☐	☐	US 20030113452	20030619	11	Metallization of non-conductive surfaces	427/304	427/305		Joshi, Nayan H.	☑	☐
4	☐	☐	☐	☐	US 20030041452	20030306	16	Filling plugs through chemical mechanical pol	29/852	257/E21.58 5;		Sinha, Nishant	☑	☐
5	☐	☐	☐	☐	US 6645557 B2	20031111	10	Metallization of non-conductive surfaces	427/304	427/305; 427/306;		Joshi; Nayan H.	☑	☐
6	☐	☐	☐	☐	US 6326317 B1	20011204	16	Method for fabricating metal oxide semiconduct	438/779	257/E21.28 6;		Wang; Hwei-Heng et al.	☑	☐
7	☐	☑	☐	☐	US 6261964 B1	20010717	91	Material removal method for forming a structure	438/705	257/E21.01 1;		Wu; Zhiqiang et al.	☑	☐
8	☐	☐	☐	☐	US 6023540 A	20000208	18	Fiber optic sensor with encoded microspheres	385/12	359/900; 385/147;		Walt; David R. et al.	☑	☐
9	☐	☐	☐	☐	US 5154897 A	19921013	8	Method and apparatus for the generation of r	423/6	210/660; 210/805;		Ehrhardt; Gary J. et al.	☑	☐
10	☐	☐	☐	☐	US 4186250 A	19800129	17	Method of desensitizing image-bearing lithograp	430/302	101/457; 101/459;		Garrett; Walter L. et al.	☑	☐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L3: (501551) etch$3.clm. or remov$3.clm.
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US 20040152284
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US 20040127008
20040701
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Method for producing integrated microsystems
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Allen, Carole et al.
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20020425
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20020404
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US 6326317 B1
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257/E21.28 6;
Wang; Hwei-Heng et al.
US 6316332 B1
20011113
11
Method for joining wafers at a low tempera
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257/E21.08 7;
Lo; Yu-Hwa et al.
US 5908562 A
19990601
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216/24; 216/49;
Ohtsu; Motoichi et al.
US 5873003 A
19990216
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Sight line detector, display unit, view find
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257/E27.13 6;
Inoue; Shunsuke et al.
US 5441603 A
19950815
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Method for chelation of pulp prior to ozone del
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162/56; 162/65;
Griggs; Bruce F. et al.
US 5426016 A
19950620
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